



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG841659249
Report verification at igi.org

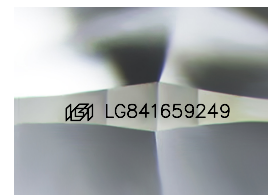
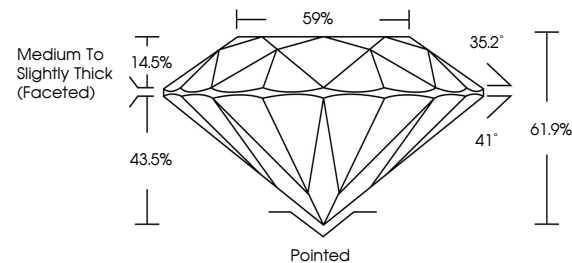
September 30, 2026	
IGI Report Number	LG841659249
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.45 - 7.48 X 4.62 MM
GRADING RESULTS	
Carat Weight	1.60 CARAT
Color Grade	D
Clarity Grade	VS 1
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG841659249

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

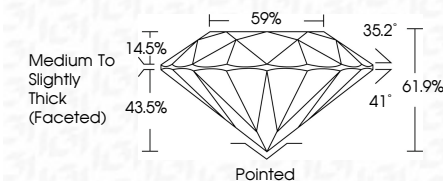
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



September 30, 2026	
IGI Report Number	LG841659249
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.45 - 7.48 X 4.62 MM
GRADING RESULTS	
Carat Weight	1.60 CARAT
Color Grade	D
Clarity Grade	VS 1
Cut Grade	IDEAL



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG841659249
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



© IGI 2020, International Gemological Institute

FD - 10 20



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK, BACKGROUND DESIGNS, HOLOGRAM, AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

September 30, 2026
ICI Report No LG841659249
ROUND BRILLIANT

7.45 - 7.48 X 4.02 MM	Carat Weight	1.60 CARAT
	Color Grade	D
	Clarity Grade	VS 1
	Cut Grade	IDEAL
	Depth	61.9%
	Table	59%
	Girdle	Medium to Slightly Thick (Faceted)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Report #	601120206

Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.